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U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					
_____	AE					

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
<u>LV</u>	AF 8-253881	10/01/96	Japan	Abstract
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OTHER DOCUMENTS

<u>LV</u>	AK	-IEEE Transaction on Magnetics, Vol. 32, pp4448-4451, September, 1996, "Ultramicro Fabrications on Fe-Ni Alloys Using Electron-Beam Writing and Reactive- Ion Etching.
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Examiner <u>LAN VINH</u>	Date Considered <u>7/26/2003</u>
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